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| APPLICATION NO.                 | FILING DATE                                       | FIRST NAMED INVENTOR | ATTORNEY DOCKET NO.     | CONFIRMATION NO. |
|---------------------------------|---|----------------------|-------------------------|------------------|
| 09/891,157                      | 06/26/2001  | Tyler Lowrey         | 2024.27                 | 2906             |
| 24963 7                         | 590 04/25/2003                                    |                      |                         | •                |
| ENERGY CONVERSION DEVICES, INC. |   |                      | EXAMINER                |                  |
|                                 | 2956 WATERVIEW DRIVE<br>ROCHESTER HILLS, MI 48309 |                      | PHAM, HOAI V            |                  |
|                                 |   |                      | ART UNIT                | PAPER NUMBER     |
|                                 |   |                      | 2814                    |                  |
|                                 |   |                      | DATE MAILED: 04/25/2003 |                  |

Please find below and/or attached an Office communication concerning this application or proceeding.

|  |  | Application No.  | Applicant(s)   |
|--|--|--|--|
| Office Action Summary  |  | 09/891,157   | LOWREY ET AL.  |
|  |  | Examiner   | Art Unit   |
|  |  | Hoai V Pham  | 2814   |
| Period f   | The MAILING DATE of this communication app<br>or Reply   | ears on the cover sheet with   | the correspondence address   |
| - External control con | MORTENED STATUTORY PERIOD FOR REPLY MAILING DATE OF THIS COMMUNICATION. ensions of time may be available under the provisions of 37 CFR 1.13 rs IX (6) MONTHS from the mailing date of this communication. e period for reply specified above is less than thirty (30) days, a reply operiod for reply is specified above, the maximum statutory period ware to reply within the set or extended period for reply will, by statute, reply received by the Office later than three months after the mailing ed patent term adjustment. See 37 CFR 1.704(b). | 36(a). In no event, however, may a rep<br>within the statutory minimum of thirty (<br>rill apply and will expire SIX (6) MONTH   | ly be timely filed  30) days will be considered timely.  IS from the mailing date of this communication. |
| 1)⊠  | Responsive to communication(s) filed on 06 M   | larch 2003 .   |  |
| 2a) <u></u>  |  | s action is non-final.   |  |
| 3) Disposit  | Since this application is in condition for alloward closed in accordance with the practice under Elion of Claims   | nce except for formal matta  | rs, prosecution as to the merits is 11, 453 O.G. 213.  |
| 4) 🖂   | Claim(s) <u>1-40,42-57,59-78,80-82,84-98,101 an</u>  | d 102 is/are pending in the  | application  |
|  | 4a) Of the above claim(s) <u>5-13,16,26-34,47-56,7</u>   |  |  |
|  | Claim(s) 40, 42-46,57-62,82,84-88 and 99-102   |  |  |
|  | Claim(s) <u>1-4,14,15,17-25,35,37-39,63-69,79,81</u>   |  |  |
|  | Claim(s) 36 and 80 is/are objected to.   |  |  |
|  | Claim(s) are subject to restriction and/or   | election requirement   |  |
| Applicati-   | on Papers  | a substitution of the subs |  |
| 9)[] 7   | The specification is objected to by the Examiner.  |  |  |
| 10)[] 1  | The drawing(s) filed on is/are: a) ☐ accepte   | ed or b) objected to by the  | Examiner.  |
|  | Applicant may not request that any objection to the  |  |  |
| 11) 🗌 T  |  | s: a) ☐ approved b) ☐ disa   |  |
|  | If approved, corrected drawings are required in reply  |  | ,  |
| 12) 🔲 T  | he oath or declaration is objected to by the Exar  | miner.   |  |
| Priority u   | nder 35 U.S.C. §§ 119 and 120  |  |  |
| 13) 🔲 ,  | Acknowledgment is made of a claim for foreign p  | priority under 35 U.S.C. § 11  | 19(a)-(d) or (f)   |
|  | ☐ All b)☐ Some * c)☐ None of:  |  | (1)  |
|  | 1. Certified copies of the priority documents h  | nave been received.  |  |
| 2  | 2. Certified copies of the priority documents h  |  | cation No  |
| 3  | B. Copies of the certified copies of the priority application from the International Bures ee the attached detailed Office action for a list of  | documents have been rec  | eived in this National Stage   |
|  | knowledgment is made of a claim for domestic p   |  |  |
| a)   | ☐ The translation of the foreign language provis   | sional application has been  | received   |
| 15) 🗌 Ac   | cknowledgment is made of a claim for domestic p  | priority under 35 U.S.C. §§  | 120 and/or 121.  |
| ttachment(s  |  | <b>33</b>  |  |
| ) 🔲 Notice   | of References Cited (PTO-892) of Draftsperson's Patent Drawing Review (PTO-948) ttion Disclosure Statement(s) (PTO-1449) Paper No(s)   | 5)   Notice of Inform  | nary (PTO-413) Paper No(s)<br>nal Patent Application (PTO-152)   |

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### **DETAILED ACTION**

### Election/Restrictions

- 1. Applicant's election without traverse of embodiment 2, figs. 1C and 2A-2S, claims 1-40, 42-57, 59-78, 80-82, 84-98 and 101-102 in Paper No. 8 is acknowledged.
- 2. Claims 5-13, 16, 26-34, 47-56, 70-78, and 89-97 are withdrawn from consideration because these claims do not read on the species of figs. 1C and 2A-2S.

## Claim Objections

3. Claim 79 is objected to because of the following informalities:

Line 3, "raised" should be changed to --protruding--.

Appropriate correction is required.

# Claim Rejections - 35 USC § 112

- 4. The following is a quotation of the second paragraph of 35 U.S.C. 112:
  - The specification shall conclude with one or more claims particularly pointing out and distinctly claiming the subject matter which the applicant regards as his invention.
- 5. Claim 14, 35, 98 are rejected under 35 U.S.C. 112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention.

Claim 14, line 3, "semiconductor, and conductor" is not described in the specification.

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Claim 35, "forming said memory material" renders the claim indefinite. It is not clear where "forming said memory material" comes from.

Claim 98, "said programmable resistance material" renders the claim indefinite. It is not clear where "said programmable resistance material" comes from.

## Claim Rejections - 35 USC § 102

6. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.
- 7. Claims 1-4, 14-15, 17-25, 35, 37-39, 63-69, 79, and 81 are rejected under 35 U.S.C. 102(e) as being anticipated by Doan et al. [U.S. Pat. 6,150,253].

With respect to claim 1, Doan et al. (figs. 1-12, cols. 6-8) discloses a method for making a programmable resistance memory element, comprising:

providing a conductive material (102) (see fig.1);

forming a sidewall spacer (104) over a portion of said conductive material (see fig.1);

removing a portion of said conductive material to form a protruding portion (114) of said conductive material under said spacer (see fig.6); and

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forming a programmable resistance material (120) adjacent to at least a portion of said raised portion (see fig.10).

With respect to claim 2, Doan et al. discloses that the removing step comprises etching said conductive material (col. 7, lines 1-5).

With respect to claim 3, Doan et al. discloses that the etching step comprises anisotropically etching said conductive material (col. 7, lines 3-5).

With respect to claim 4, Doan et al. discloses that the etching step comprises isotropically etching said conductive material (col. 7, lines 3-5).

With respect to claim 14, Doan et al. discloses that the sidewall spacer (104) comprises a dielectric (col. 6, line 40).

With respect to claims 17-18, Doan et al. discloses that the programmable resistance material (120) comprises a phase change material (a chalcogen element) (col. 7, lines 55-59).

With respect to claim 19, Doan et al. (figs. 1-12, cols. 6-8) discloses a method for making a programmable resistance memory element, comprising:

providing a conductive layer (102) (fig. 1);

forming a protruding portion (114) of said conductive layer extending from an edge of said conductive layer (fig. 6); and

forming a programmable resistance material (120) adjacent to at a least a portion of said protruding portion (fig. 10).

With respect to claim 20, Doan et al. discloses that the forming said protruding portion step comprises:

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forming a mask (104) over a portion of said edge (fig. 5); and removing a portion of said conductive layer to form said protruding portion under said mask (fig. 6).

With respect to claim 21, Doan et al. discloses that the removing step comprises etching said conductive layer (col. 7, lines 1-5).

With respect to claim 22, Doan et al. discloses that the etching step comprises anisotropically etching said conductive layer(col. 7, lines 3-5).

With respect to claim 23, Doan et al. discloses that the etching step comprises isotropically etching said conductive layer (col. 7, lines 3-5).

With respect to claim 24, Doan et al. discloses that the mask has a lateral dimension less than 1000 Angstoms (col. 6, lines 40-42).

With respect to claim 25, Doan et al. discloses that the mask is a sidewall spacer and forming said mask step comprises forming said sidewall spacer (fig. 5).

With respect to claim 35, Doan et al. discloses that the forming said programmable resistance material step comprises forming said programmable resistance material adjacent to a top surface of said protruding portion (fig. 10).

With respect to claim 37, Doan et al. discloses that the conductive layer is a conductive sidewall layer or a conductive sidewall liner (fig. 1).

With respect to claims 38-39, Doan et al. discloses that the said programmable resistance material comprises a phase change material (a chalcogen element) (col. 7, lines 55-59).

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With respect to claim 63, Doan et al. (figs. 1-12, cols. 6-8) discloses a method for making an electrode for a semiconductor device, comprising:

providing a conductive layer (102) (fig. 1); and

forming a protruding portion (114) extending from an edge of said conductive layer (fig. 6).

With respect to claim 64, Doan et al. discloses that the forming said protruding portion (114) step comprises: forming a mask (104) over a portion of said edge (fig. 5); and removing a portion of said conductive layer to form said protruding portion under said mask (fig. 6).

With respect to claim 65, Doan et al. discloses that the removing step comprises etching said conductive layer (col. 7, lines 1-5).

With respect to claim 66, Doan et al. discloses that the said etching step comprises anisotropically etching said conductive layer (col. 7, lines 3-5).

With respect to claim 67, Doan et al. discloses that the etching step comprises isotropically etching said conductive layer(col. 7, lines 3-5).

With respect to claim 68, Doan et al. discloses that the mask has a lateral dimension less than 1000 Angstoms (col. 6, lines 40-42).

With respect to claim 69, Doan et al. discloses that the said mask, is a sidewall spacer and forming said mask step comprises forming said sidewall spacer (fig. 5).

With respect to claim 79, Doan et al. discloses that the forming said memory material step comprises forming said programmable resistance material adjacent to a top surface of said protruding portion (fig. 10).

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With respect to claim 81, Doan et al. discloses that the conductive layer is a conductive sidewall layer or a conductive sidewall liner (fig. 1).

## Allowable Subject Matter

- 8. Claims 40, 42-46, 57-62, 82, 84-88, and 99-102 allowed.
- 9. Claims 36 and 80 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.
- The following is a statement of reasons for the indication of allowable subject 10. matter: the prior art of record fails to disclose the steps of forming a sidewall surface in the dielectric layer; forming a conductive layer on the sidewall surface and forming a protruding portion extending from the edge of the conductive layer while having the characteristics as recited in claims 40 and 82.

### Conclusion

- 11. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Hoai V Pham whose telephone number is 703-308-6173. The examiner can normally be reached on 6:30A.M. - 6:00P.M..
- 12. If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Wael M. Fahmy can be reached on 703-308-4918. The fax phone numbers for the organization where this application or proceeding is assigned are 703-308-7722 for regular communications and 703-308-7724 for After Final communications.

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13. Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 703-308-0956.

HP Hoai Pham April 18, 2003

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